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addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA
22313-1450, on the date shown below

Dated:

2/2/09

Signature:

Eileen Sheffield
(Eileen Sheffield)

Docket No.: NY-RPP-202
(10510421)
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
BECKMANN

Application No.: 10/552,677

Group Art Unit: 1792

Filed: November 21, 2005

Examiner: N. K. Ford

For: HIGH FREQUENCY PLASMA JET SOURCE
AND METHOD FOR IRRADIATING A
SURFACE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:


Responsive to the office action mailed August 5, 2008, please grant a three month extension of time. Please charge the fee, believed to be \$555.00 to a credit card.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this

application by this firm) to our Deposit Account No. 50-0624, under Order No. NY-RPP-202-US.

Dated: 2/2/09

Respectfully submitted,

By 

James R. Crawford

Registration No.: 39,155

FULBRIGHT & JAWORSKI L.L.P.

666 Fifth Avenue

New York, New York 10103

(212) 318-3000

(212) 318-3400 (Fax)

Attorney for Applicant